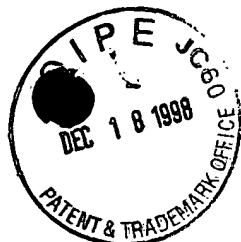


35.C11946



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE **RECEIVED**

In re Application of:

JAN 22 1999

AKIRA FUNAKOSHI, ET AL.

TECHNOLOGY CENTER 3700

Appln. No.: 08/801,464

Examiner: C. Dexter

Filed: February 18, 1997

Group Art Unit: 3724

For: SUBSTRATE CUTTING METHOD
AND SUBSTRATE CUTTING
APPARATUS

December 18, 1998

The Assistant Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR OFFICIAL FILING RECEIPT

Sir:

To date, Applicants have not received an official Filing Receipt for the above-identified application. Accordingly, Applicants request that the U.S. Patent and Trademark Office promptly issue an official Filing Receipt for this application.

Favorable consideration is requested.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our new address listed below.

Respectfully submitted,



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*Done
b/Donald
1-20-99*